

Application/Control No.	Applicant(s)/Patent under Reexamination YIREN HONG	
10/695,253		
Examiner	Art Unit	
Yahveh Comas	2834	

SEARCHED						
Class	Subclass	Date	Examiner			
310	51, 67r	3/4/2005	YC			
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
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